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6/20/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:
White, et al.

Serial No.: 10/066,131

Confirmation No.: 3348

Filed: January 30, 2002

For: Method and Apparatus for
Substrate Processing

Group Art Unit: 2821

Examiner: Chuc Tran

TECHNOLOGY CENTER 2800

JUN 18 2003

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on 6/12/03 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
6/12/03 Date	<i>Kevin R. Z...</i> Signature

RESPONSE TO OFFICE ACTION DATED MARCH 13, 2002

In response to the Office Action dated March 13, 2003, having a shortened statutory period for response set to expire on June 13, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/6148/KMT, the fee of \$588.00 for 7 additional independent claims, and any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

IN THE CLAIMS:

Please cancel claims 6 and 10, and amend the claims as follows:

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- (Amended) An apparatus for substrate processing, comprising:
a chamber comprising a bottom, a top, and a body disposed between the bottom and the top;

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